

# Design of bandpass filters composed of dielectric layers separated by gratings of strip conductors

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We derive the design formulas for novel multilayer bandpass filters in which every dielectric layer (resonator) is separated from the adjacent layer or external medium by a grating of strip conductors. Every grating acts as a semi-reflecting mirror. Such novel filters have wide stop bands compared to conventional filters with multilayer dielectric mirrors between resonators at the same passband width. The parameters of the lowpass, lumped-element prototype filter, as well as the theory of resonator-coupling coefficients, are considered in our approach. The computed frequency response of the fifth-order Chebyshev filter that was synthesized using the proposed formulas is also presented. © 2016 Optical Society of America

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A novel multilayer bandpass filter containing interlayer gratings of strip conductors was proposed in [1]; the cross section of its structure is shown in Fig. 1. The filter works similarly to the conventional dielectric multilayer bandpass filter for which multilayer dielectric mirrors separating half-wavelength resonant layers are composed of quarter-wavelength layers with alternating high- and low-refractive indices [2–5]. The salient feature of the novel filter is its stop bands are extended manifold. This filter may operate in microwave, infrared, and optical ranges.

Every dielectric layer in the filter under consideration is a half-wavelength resonator. It is separated from the adjacent resonator or free space by semi-reflecting mirrors located on both of its sides. Each mirror is a planar grating of strip conductors, and the conductors in all the gratings are parallel to each other. Every period  $T_i$  for the  $i$ th grating in the filter must be less than the thickness  $h_i$  of the adjacent dielectric layers in order to suppress the contribution of evanescent modes generated by the grating. The third set of structure parameters of the filter is

the spacing  $s_i$  between strip conductors. All three sets of parameters have to have their optimal values corresponding to index  $i$ .

The behavior of the reflection properties of the single grating with the ideal strip conductors situated on a boundary between two media when its structure parameters vary was studied in [6]. In that paper, one can also find the derived formulas for the reflection and transmission coefficients, which we use during filter design.

In this Letter, we derive formulas for computing the optimal values of  $s_i$  and  $h_i$  at fixed values of  $T_i$  for every layer of the structure in order to ensure the desired Chebyshev frequency response of the filter. We restrict ourselves to the case in which the wave vector of the incident wave is orthogonal to the filter plane and the electric field  $\mathbf{E}$  is parallel to the strip conductors.

We shall characterize the frequency response near the passband by the frequencies  $f_l$  and  $f_h$ , which are the low and high edges of the passband as defined by the minimum return loss level  $L_r$  (i.e., the reflection loss measured in decibels). The order  $n_f$  of the filter defines the number of reflection zeroes within the passband and is equal to the number of layers.

In accordance with the theory of filters, the only physical values that are to be adjusted in order to obtain the desired passband parameters ( $L_r$ ,  $f_l$ , and  $f_h$ ) are the resonant frequencies of all the resonators,  $f_i$ ; the coupling coefficients of all the resonator pairs,  $k_{i,i+1}$ ; and the external quality factor of the input and output resonators,  $Q_e$ . In the case of a narrow passband, all the resonant frequencies  $f_i$  must be equal to the center frequency  $f_0 = (f_l f_h)^{1/2}$ . Moreover, the coefficients  $k_{i,i+1}$ , together with the factor  $Q_e$ , must satisfy the following equations [7,8]:

$$Q_e^{-1} = w/g_1, \quad (1)$$

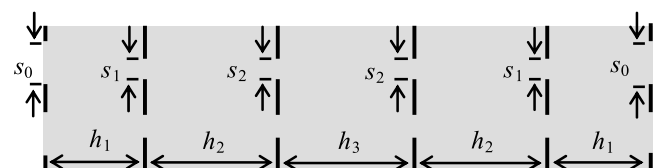


Fig. 1. Cross section of the fifth-order bandpass filter.

$$|k_{i,i+1}| = w/\sqrt{g_i g_{i+1}}, \quad (2)$$

where  $w$  is the fractional bandwidth defined by the equation

$$w \equiv (f_b - f_l)/f_0, \quad (3)$$

and  $g_i$  are the normalized lowpass prototype parameters that can be computed using the following equations:

$$\begin{aligned} g_1 &= 2a_1/\gamma, \\ g_k &= \frac{4a_{k-1}a_k}{b_{k-1}g_{k-1}}, \quad k = 2, 3, \dots, n_f. \end{aligned} \quad (4)$$

Here we use the following notations:

$$\begin{aligned} \gamma &= \sinh\left(\frac{\operatorname{atanh}\sqrt{1-10^{-L_r/10}}}{2n_f}\right), \\ g_1 &= 2a_1/\gamma, \\ g_k &= \frac{4a_{k-1}a_k}{b_{k-1}g_{k-1}}, \quad k = 2, 3, \dots, n_f, \\ a_k &= \sin\frac{(2k-1)\pi}{2n_f}, \\ b_k &= \gamma^2 + \sin^2\frac{k\pi}{n_f}, \quad k = 1, 2, \dots, n_f. \end{aligned} \quad (5)$$

We should note that the coefficients  $k_i$  are symmetrical relative to the filter center—i.e.,  $k_1 = k_{n-1}$ ,  $k_2 = k_{n-2}$  etc.

In order to determine the factor  $Q_e$  of the input resonator ( $i = 1$ ), including the first dielectric layer together with the external grating ( $i = 0$ ) that separates the layer from free space, we should isolate this resonator from the neighboring resonator. This may be theoretically achieved by applying the boundary condition  $\mathbf{E} = 0$  for the electric field on the isolated surface of the first layer. At this stage, we can solve the boundary-value problem and find the complex frequency  $f_c$  for free oscillation in the first resonator.

We shall characterize the reflective properties of every grating on the boundary between media with refractive indices  $n_1$  and  $n_2$  by the scattering matrix  $\mathbf{S}(n_1, n_2, f, s, T)$ . This matrix relates the normalized electric-strength amplitudes of outgoing waves ( $b_i$ ), with the analogous amplitudes of the incoming waves ( $a_i$ ) on both sides (port 1 and port 2), according to the following equation [9]:

$$\begin{pmatrix} b_1 \\ b_2 \end{pmatrix} = \mathbf{S} \begin{pmatrix} a_1 \\ a_2 \end{pmatrix}. \quad (6)$$

Here the amplitudes  $a_i$  and  $b_i$  are normalized in such a way that the total power  $P_i$  coming into port  $i$  per unit area can be expressed by the equation

$$P_i = \frac{1}{2}|a_i|^2 - \frac{1}{2}|b_i|^2. \quad (7)$$

Using the formulas for reflection and transmission coefficients that were derived in [6], we obtain the scattering matrix for the grating

$$\begin{aligned} \mathbf{S}(n_1, n_2, f, s, T) &= \begin{pmatrix} \frac{n_1 - n_2 - i\Lambda}{n_1 + n_2 + i\Lambda} & \frac{2\sqrt{n_1 n_2}}{n_1 + n_2 + i\Lambda} \\ \frac{2\sqrt{n_1 n_2}}{n_1 + n_2 + i\Lambda} & \frac{-n_1 + n_2 + i\Lambda}{n_1 + n_2 + i\Lambda} \end{pmatrix} \\ \Lambda &\equiv c/\left[fT \ln \sec\left(\frac{\pi s}{2T}\right)\right], \end{aligned} \quad (8)$$

where  $i$  is the imaginary unit that is present in the time-dependent factor  $\exp(-i2\pi f t)$ .

Solving the eigenvalue problem concerning the free oscillation in the first resonator, we obtain the following equation:

$$\theta_c = \pi + \frac{i}{2} \ln(-S_{11}(n, 1, f_c, s_0, T_0)), \quad (9)$$

where  $n$  is the refractive index of all the layers, and  $\theta_c$  is phase thickness of the first layer as defined by the following equation:

$$\theta_c \equiv \frac{2\pi f_c}{c} n b_1. \quad (10)$$

The frequency  $f_c$  together with thickness  $b_1$  may be easily found by iteratively solving Eq. (10) under the condition  $\operatorname{Re} f_c = f_0$ . At this stage, the factor  $Q_e$  may be computed using the following equation [6,10]:

$$Q_e = \operatorname{Re} f_c / (-2 \operatorname{Im} f_c). \quad (11)$$

We can simultaneously estimate the relative thinning of the first layer, affected by the external grating, using the following equation:

$$\delta l_0 = 1 - \operatorname{Re} \theta_c / \pi. \quad (12)$$

Now the optimal value of  $s_0$  in the external grating may be found for a fixed value of  $T_0$  by solving Eq. (1).

In order to determine the coupling coefficients  $k_{i,i+1}$  for the  $i$ th and  $(i+1)$ th resonators, we should isolate this pair from all other parts of the filter. This can be theoretically achieved by applying the boundary condition  $\mathbf{E} = 0$  for the electric field on both external surfaces of this resonator pair.

Next, we compute the resonant frequencies  $f_e$  and  $f_o$  for the even- and odd-coupled oscillations for the case of identical layers. Solving this eigenvalue problem, we obtain the following equations:

$$\theta_e = \pi + i\frac{1}{2} \arg(-S_{21} - S_{11}), \quad (13)$$

$$\theta_o = \pi + i\frac{1}{2} \arg(S_{21} - S_{11}). \quad (14)$$

For phase thicknesses, we have

$$\begin{aligned} \theta_e &\equiv \frac{2\pi f_e}{c} n b_i, \\ \theta_o &\equiv \frac{2\pi f_o}{c} n b_i. \end{aligned} \quad (15)$$

Taking Eq. (8) into account, we can rewrite Eq. (14) for the case of  $n_1 = n_2 = n$  in the following form:

$$\theta_o = \pi. \quad (16)$$

The frequencies  $f_e$  and  $f_o$  together with the thickness  $b_i$  may be found by iteratively solving Eqs. (13), (15), and (16) under the condition that  $(f_e + f_o)/2 = f_0$ . Next, the coefficients  $k_{i,i+1}$  may be computed using the following equation [11,12]:

$$k_{i,i+1} = (f_o^2 - f_e^2)/(f_o^2 + f_e^2). \quad (17)$$

We can simultaneously estimate the relative thinning of the  $i$ th layer, affected by  $i$ th grating, as follows:

$$\delta l_i = 1 - (\theta_e + \theta_o)/(2\pi). \quad (18)$$

Now the optimal value of  $s_i$  in the  $i$ th grating may be found for a fixed value of  $T_i$  by solving Eq. (2).

At this stage, the final thicknesses of the dielectric layers in accordance with Eqs. (10), (12), (15), and (18) may be computed as follows:

$$h_i = (1 - \delta l_{i-1} - \delta l_i)\lambda_n/2, \quad (19)$$

where  $\lambda_n = c/(f_0 n)$  is the wavelength in the dielectric at  $f_0$ . In this way, we have obtained all the formulas that allow for the design of the multilayer passband filter.

The frequency response of the designed filter may be computed by multiplication of the transfer matrices  $\mathbf{M}$  for every grating and every dielectric layer in the multilayer structure [2]. Matrix  $\mathbf{M}$  is also called the characteristic matrix or the ABCD matrix [7]. It relates the tangential components of the electric- and magnetic-field strengths on the first and second surface of a planar structure according to the following equation:

$$\begin{pmatrix} E_1 \\ Z_0 H_1 \end{pmatrix} = \mathbf{M} \begin{pmatrix} E_2 \\ Z_0 H_2 \end{pmatrix}, \quad (20)$$

where the free-space characteristic impedance is given by  $Z_0 \equiv (\mu_0/\epsilon_0)^{1/2}$ .

The transfer matrix  $\mathbf{M}$  of the  $i$ th dielectric layer has the following form [2]:

$$\mathbf{M} = \begin{pmatrix} \cos \theta_i & \frac{-i}{n} \sin \theta_i \\ -in \sin \theta_i & \cos \theta_i \end{pmatrix}, \quad \theta_i \equiv \frac{2\pi f}{c} n h_i, \quad (21)$$

whereas the transfer matrix  $\mathbf{M}$  of the grating may be obtained from Eq. (8) by the following equation [7]:

$$\mathbf{M} = \begin{pmatrix} \frac{1 + S_{11} - S_{22} - \det[S_{ik}]}{2S_{21}} & \frac{1 + S_{11} + S_{22} + \det[S_{ik}]}{2S_{21}} \\ \frac{1 - S_{11} - S_{22} + \det[S_{ik}]}{2S_{21}} & \frac{1 - S_{11} + S_{22} - \det[S_{ik}]}{2S_{21}} \end{pmatrix}. \quad (22)$$

The required scattering matrix  $\mathbf{S}$  of the entire layered structure is related to the product ( $\mathbf{M}$ ) of the transfer matrices for every structure component as follows [7]:

$$\mathbf{S} = \begin{pmatrix} \frac{M_{11} + M_{12} - M_{21} - M_{22}}{M_{11} + M_{12} + M_{21} + M_{22}} & \frac{2 \det[M_{ik}]}{M_{11} + M_{12} + M_{21} + M_{22}} \\ \frac{M_{11} + M_{12} + M_{21} + M_{22}}{2} & \frac{-M_{11} + M_{12} - M_{21} + M_{22}}{M_{11} + M_{12} + M_{21} + M_{22}} \end{pmatrix}. \quad (23)$$

Equations (22) and (23) are concerned with the particular case in which both media surrounding the filter are air.

We should note that the filter being considered, as well as its components (dielectric layers and gratings of strip conductors), are reciprocal two-port networks. Thus their matrices  $\mathbf{M}$  and  $\mathbf{S}$  satisfy the equations  $\det[M_{ik}] = 1$  and  $S_{12} = S_{21}$  [7]. Moreover, the neglect of dielectric and ohmic loss in the structure results in the following equation:  $|S_{11}| = |S_{22}|$ .

We shall illustrate the accuracy of our derived design formulas with the following example. Let the desired filter have

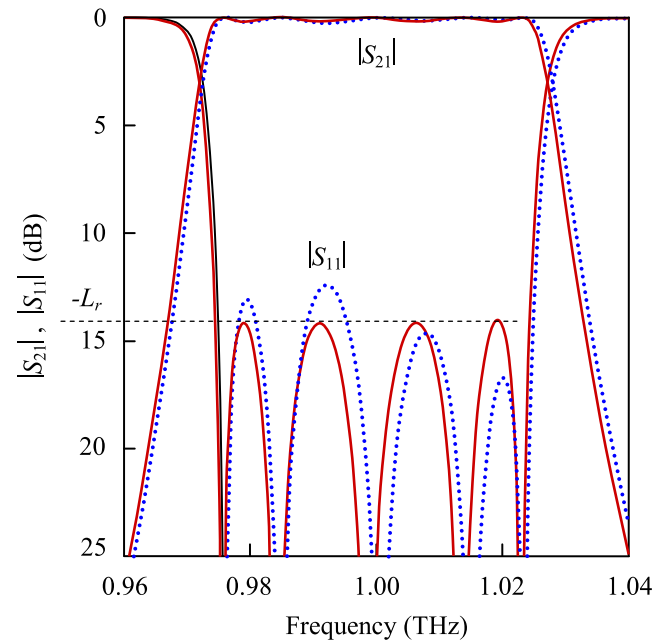
**Table 1. Structure Parameters of the Filter (all units:  $\mu\text{m}$ )**

Parameter	$s_0$	$s_1$	$s_2$	$h_1$	$h_2$	$h_3$
Formulas	33.91	16.92	15.08	70.04	77.47	77.79
Optimal	33.95	16.86	15.08	70.14	77.53	77.85

the order  $n_f = 5$ ; let the passband, edge frequencies be  $f_l = 0.975$  THz and  $f_h = 1.025$  THz; let the minimum return loss level be  $L_r = 14$  dB; and let the refractive index be  $n = 1.87$ . From these parameters, we obtain a center frequency of  $f_0 = 1$  THz, a fractional bandwidth of  $w = 0.050$ , an external quality factor of  $Q_e = 26.00$ , coupling coefficients of  $k_{1,2} = 0.03781$  and  $k_{2,3} = 0.02956$ , and a wavelength of  $\lambda_n = 160.2 \mu\text{m}$  in the dielectric. We shall suppose that all the gratings have the same period: namely,  $T_i = \lambda_n/4$  (i.e.,  $T_i = 40 \mu\text{m}$ ). In this way, we obtain the spacing of the gratings and the thicknesses of the layers. Their values, measured in micrometers, are presented in the row labeled as ‘‘Formulas’’ in Table 1.

The dotted lines in Fig. 2 show the computed frequency dependencies of the transmission coefficient  $|S_{21}|$  and the reflection coefficient  $|S_{11}|$  for the bandpass filter that was designed by the proposed formulas. One can see that the designed filter requires slight adjustments. Using physical rules of filter optimization [3], we obtained the refined structure parameters, which are presented in the row labeled as ‘‘Optimal’’ in Table 1.

We should note that the accuracy of the proposed design formulas decays with an increase in the fractional bandwidth  $w$ . This accuracy decay appears in any filter that is designed with use of its lumped-element prototype [7]. Furthermore, the inaccuracy is due to the difference of frequency dispersion of the resonator-coupling coefficients in the filter and the dispersion of the corresponding coefficients in its lumped-element prototype [13,14].



**Fig. 2.** Computed frequency responses of the bandpass filter for the structure parameters obtained by the formulas derived in this Letter (dotted lines) and by optimization (solid lines).

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